

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Toru TATSUMI, et al.  
Title: SEMICONDUCTOR DEVICE HAVING A MIS-TYPE FET,  
AND METHODS FOR MANUFACTURING THE SAME AND  
FORMING A METAL OXIDE FILM  
Appl. No.: Unassigned  
Filing Date: 11/28/2005  
Examiner: Unassigned  
Art Unit: Unassigned

**PRELIMINARY AMENDMENT UNDER 37 CFR 1.115**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present Application, Applicant respectfully requests that the application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 8 of this document.

Please amend the application as follows: